

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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Inventor..... Y. Hishiro  
Assignee ..... Micron Technology, Inc.  
Group Art Unit..... unknown  
Examiner ..... unknown  
Attorney's Docket No. .... MI22-2507  
Customer No. .... 021567  
Title: Methods Of Forming Semiconductor Constructions

**PRELIMINARY AMENDMENT**

To: Mail Stop Patent Application  
Commissioner for Patents  
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**AMENDMENTS**

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